

AFF/2815

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ohtani, et al. Art Unit : 2815
Serial No.: 09/379,702 Examiner : Eugene Lee
Filed : August 24, 1999
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

Commissioner for Patents
Washington, D.C. 20231

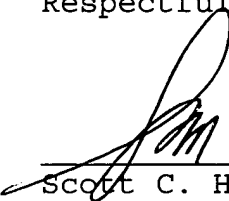
RECEIVED
TECHNOLOGY CENTER 2000
SEP 27 2001TRANSMITTAL LETTER

Correspondence relating to this application is enclosed.
The required fees are computed below. Please apply any charges
not covered, or any credits, to Deposit Account No. 06-1050.

Total Claims	40	-	43	=	0	\$0
Independent	10	-	10	=	0	\$0
TOTAL FEE DUE						\$0

Respectfully submitted,

Date: 9/21/01



Scott C. Harris
Reg. No. 32,030

Fish & Richardson P.C.
PTO Customer No. 02985
4350 La Jolla Village Drive, Suite 500
San Diego, California 92122
Telephone: (858) 678-5070
Facsimile: (858) 678-5099

10135474.doc

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this
correspondence is being deposited with the
United States Postal Service as first class mail
with sufficient postage on the date indicated
below and is addressed to the Commissioner for
Patents, Washington, D.C. 20231.

September 21, 2001
Date of Deposit Nancy Grant
Signature Nancy Grant
Typed or Printed Name of Person Signing
Certificate